

09/540288

UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION

PATENT NO. : 6,771,019 B1
DATED : August 3, 2004
INVENTOR(S) : Wu et al.

Page 1 of 2

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Column 41,

Line 32, after "phosphor deposits" insert -- , said at least first and second phosphor deposits being formed from phosphors of different host materials --.

Column 43,

Line 30, delete "a threshold voltage adjustment layer selected" and replace with -- the threshold voltage adjustment layer being selected --.

Line 61 delete "a threshold voltage adjustment layer selected" and replace with -- the threshold voltage adjustment layer being selected --.

Column 44,

Line 51, delete "a threshold voltage" and replace with -- the threshold voltage --.

Column 45,

Lines 3-4, delete "a threshold voltage adjustment layer selected" and replace with -- the threshold voltage adjustment layer being selected --.

Line 64, after "dielectric layer" insert --, S is the dielectric strength of the dielectric layer --.

Column 49,

Line 30, delete "a threshold voltage adjustment layer selected" and replace with -- the threshold voltage adjustment layer being selected --.

Line 56, delete "a thickness" and replace with -- the thickness --.

Line 59, after "dielectric layer" insert -- , S is the dielectric strength of the dielectric layer --.

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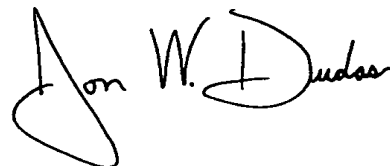
It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Column 52.

Lines 12-13, delete "a threshold voltage" and replace with -- the threshold voltage --.
Lines 29-30, delete "a threshold voltage adjustment layer selected" and replace with
-- the threshold voltage adjustment layer being selected --.

Signed and Sealed this

Eighth Day of February, 2005

A handwritten signature in black ink, reading "Jon W. Dudas". The signature is stylized, with a large loop for the "J" and a cursive "Dudas".

JON W. DUDAS
Director of the United States Patent and Trademark Office